

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L5	2215	(source with (gate or shutter or door)) same (o-ring or gasket or seal)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 16:07
L6	2500	((source or evaporator or vaporizer) with (gate or shutter or door)) same (o-ring or gasket or seal)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 16:08
L7	948	((source or evaporator or vaporizer) same (gate or shutter or door) with(o-ring or gasket or seal))	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 16:08
L8	348	7 and (wafer or substrate)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 16:09
L9	140	((((deposit\$3 or material or solid or liquid) adj2 source) or evaporator or vaporizer) same (gate or shutter or door)) with(o-ring or gasket or seal)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 16:11
L10	36	9 and (wafer or substrate)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 16:11

L11	4	((((deposit\$3 or material or solid or liquid) adj2 source) or evaporator or vaporizer) with (alumina or "al. sub.2o.sub.3")) same ((alumina or "al.sub.2o. sub.3") with (flat or smooth))	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 18:04
L12	27	((((deposit\$3 or material or solid or liquid) adj2 source) or evaporator or vaporizer) with (alumina or "al. sub.2o.sub.3")) and ((alumina or "al.sub.2o. sub.3") with (flat or smooth))	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 18:07
L13	23	12 not 11	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 18:09
L14	947	((((deposit\$3 or material or solid or liquid) adj2 source) or evaporator or vaporizer) with (alumina or "al. sub.2o.sub.3"))	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 18:13
L16	920	14 not 12	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 18:13
L17	347	16 and (wafer or substrate)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 18:13

L18	99	crucible with (alumina or "al. sub.2o.sub.3") and ((alumina or "al.sub.2o. sub.3") with (flat or smooth))	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 18:22
L19	4663	crucible with (alumina or "al. sub.2o.sub.3")	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 19:44
L20	1740	19 and (wafer or substrate)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 19:45
L21	511	20 and vapor near3 deposition	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 19:45
L22	10	21 and ((alumina or "al. sub.2o.sub.3") with (flat or smooth))	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 19:46
L23	47	pumps! with (inert or purge or carrier) adj2 gas with between	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 20:13
L24	5	23 and (wafer or substrate)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 20:13
L25	846	pumps! with (inert or purge or carrier) adj2 gas	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 20:19
L26	326	25 and (wafer or substrate)	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 20:19
L27	321	26 not 24	US-PGPUB; USPAT; USOCR	OR	ON	2009/02/09 20:19
S107	50	Knudsen adj cells with shutter	US-PGPUB; USPAT	OR	ON	2009/02/07 10:45

2/9/2009 9:04:18 PM

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